

What is claimed is:

1. A semiconductor device comprising:

a semiconductor element including an electrode formed on an electrode-formed surface thereof;

5 a reinforcing member bonded to a back surface of said semiconductor element, said back surface being opposite to said electrode-formed surface; and

an adhesive bonding said semiconductor element and said reinforcing member while allowing said semiconductor element to be deformed.

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2. The semiconductor device of claim 1, wherein said adhesive is made of resin having a low elastic modulus, and bonds said back surface of said semiconductor element entirely to said reinforcing member.

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3. The semiconductor device of claim 1, wherein said adhesive bonds only a center of said back surface of said semiconductor element to said reinforcing member.

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4. The semiconductor device of claim 1, wherein said reinforcing member has a flexural rigidity greater than a flexural rigidity of said semiconductor element.

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5. The semiconductor device of claim 1, wherein said reinforcing member is larger than said semiconductor element in outside shape.

6. The semiconductor device of claim 5, wherein said reinforcing member includes:

a recess portion to which said semiconductor element is bonded; and  
a projection formed at a border of said recess portion.

7. The semiconductor device of claim 1, wherein said reinforcing  
5 member functions as a holding member in handling.

8. The semiconductor device of claim 1, wherein an identification  
information is applied to an applied surface of said reinforce member, said  
applied surface being opposite to a surface bonded to said semiconductor  
10 element.

9. A method of manufacturing a semiconductor device, comprising the  
steps of:

shaving a back surface of a semiconductor wafer, said back surface  
15 being opposite to an electrode-formed surface of said semiconductor wafer  
including a plurality of semiconductor elements therein;

bonding a reinforcing plate to the shaved back surface of the  
semiconductor wafer with an adhesive; and

dividing the semiconductor wafer to which the reinforcing member is  
20 bonded and the reinforcing plate into units of the semiconductor elements.

10. The method of claim 9, wherein said step of dividing the  
semiconductor wafer and the reinforcing plate includes the sub step of  
dividing the reinforcing plate with a dicing width smaller than a dicing width  
25 of the semiconductor wafer.

11. The method of claim 9, further comprising the step of attaching a

sheet to the electrode-formed surface of the semiconductor wafer, wherein said step of shaving the back surface of the semiconductor wafer includes the sub step of shaving the back surface of the semiconductor wafer while the sheet is attached to the electrode-formed surface of the semiconductor wafer.

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12. The method of claim 9, further comprising the step of forming a bump on the electrode-formed surface of the semiconductor wafer.

10 13. A method of manufacturing a semiconductor device, comprising the steps of:

forming a diced groove along a border between a plurality of semiconductor elements from an electrode-formed surface of a semiconductor wafer which includes the semiconductor elements formed therein;

15 attaching a sheet to the electrode-formed surface of the semiconductor wafer having the diced groove;

dividing the semiconductor wafer into the semiconductor elements through shaving a back surface of the semiconductor wafer to thin the semiconductor wafer to a thickness until the shaved back surface reaches the diced groove, said back surface being opposite to the electrode-formed surface  
20 to which the sheet is attached;

bonding a reinforcing plate to the back surface of the semiconductor elements with an adhesive; and

dividing the reinforcing plate into units of the semiconductor elements after removing the sheet from the electrode-formed surface.

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14. The method of claim 13, wherein said step of dividing the reinforcing plate includes the sub step of dividing the reinforcing plate with a